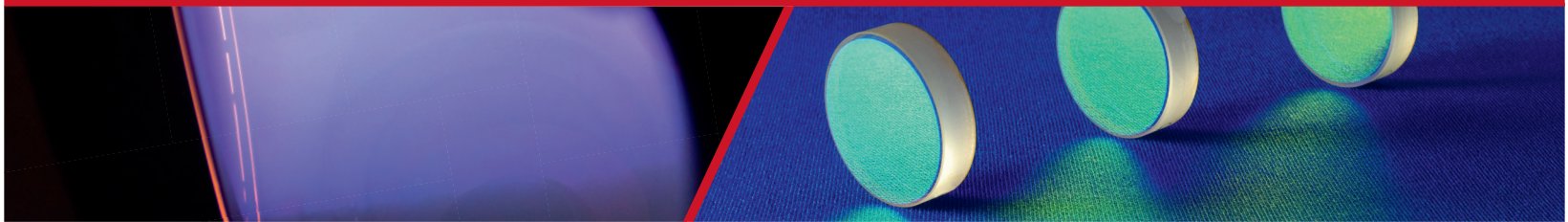
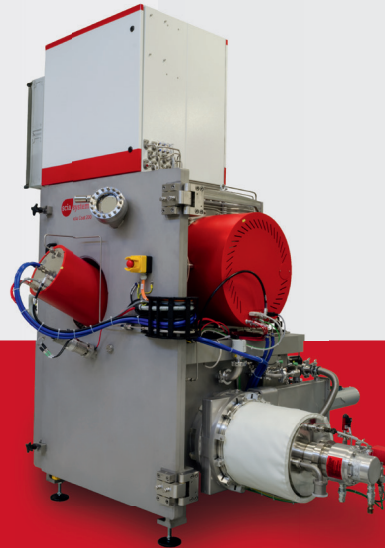


## Solutions for Thin Film Technology



### Technology Portfolio

- ⇒ Ion Beam Trimming (IBT)
- ⇒ Ion Beam Etching and Milling (IBE/IBM)
- ⇒ Dual Ion Beam Deposition (DIBD)
- ⇒ Physical Vapor Deposition (PVD)
- ⇒ Plasma Enhanced Chemical Vapor Deposition (PECVD)
- ⇒ Reactive Ion Etching (RIE)
- ⇒ Plasma Cleaning



### Tool Configurations

- ⇒ Batch systems
- ⇒ Single wafer load-lock
- ⇒ Cassette load-lock
- ⇒ Cluster systems
- ⇒ Large area inline systems

### Contact information

**scia Systems GmbH**  
Annaberger Straße 240  
09125 Chemnitz  
Germany

E-mail: [info@scia-systems.com](mailto:info@scia-systems.com)  
Web: [www.scia-systems.com](http://www.scia-systems.com)

### Sales Partner India

**PACE Analytical Systems**  
No. 878, BEML Lay out Road, Dwarakanagar,  
Channasandra, Rajarajeshwarinagar,  
Bangalore, Karnataka, 560 098  
India  
E-mail: [suresh@paceanalytical.in](mailto:suresh@paceanalytical.in)  
Web: [www.paceanalytical.in](http://www.paceanalytical.in)